

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Joseph B. Bernstein and Zhihui Duan

Application No.: 08/825,808

Group Art Unit: 2812

Filed: April 3, 1997

Examiner: L. Gurley

For: LASER-INDUCED CUTTING OF METAL INTERCONNECT



CERTIFICATE OF MAILING	
I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to Assistant Commissioner for Patents, Washington, D.C. 20231	
on <u>2-10-99</u>	<u>Claire J. Hamilton</u>
Date	Signature
<u>CLAIRE J. HAMILTON</u>	
Typed or printed name of person signing certificate	

REPLY TO RESTRICTION REQUIREMENT

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

Responsive to the Restriction Requirement dated January 14, 1999, the claims of Group I (Claims 20-41) drawn to a method of making a semiconductor device are elected for prosecution. Applicant reserves the right to file a continuing application or take such other appropriate action as deemed necessary to protect the invention of Group II (Claims 1-19). Applicant does not hereby abandon or waive any rights in the Group II invention.

Respectfully submitted,

HAMILTON, BROOK, SMITH & REYNOLDS, P.C.

By 

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J. Hamilton
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